

## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 2023I
www.uspto.gov

## \*BIBDATASHEET\*

**CONFIRMATION NO. 3186** 

Bib Data Sheet

SERIAL NUMBER 10/658,422	FILING DATE 09/10/2003 RULE	CLASS 427	GROUP ART UNIT 1762		ATTORNEY DOCKET NO. 241812US3DIV		
APPLICANTS  Kazuto Kinoshita, Tukuba-shi, JAPAN;							
Kazuhiko Gommori, Naka-gun, JAPAN; Kenya Wada, Naka-gun, JAPAN;							
** CONTINUING DATA **********************************							
** FOREIGN APPLICATIONS ************************************							
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/02/2003							
Foreign Priority claimed  35 USC 119 (a-d) conditions met  Verified and Acknowledged  Example 1	STATE OR  STATE OR  COUNTRY  JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 3		INDEPENDENT CLAIMS 3		
ADDRESS 22850 OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA , VA 22314							
TITLE Apparatus and method for processing a substrate							
No	No to charge/credit DEPOSIT ACCOUNT EIVED No for following:			All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)  1.18 Fees (Issue)  Other  Credit			